Subst. Form PTO-1449 FORMATION DISCLOSURE CITATION IN AN APPLICATION						nber (Optional)	Application Number 10/775,270		
					Young-Kwang Kim, et al. Filing Date Group Art Unit				
(Use several sheets if necessary)					02/10/04 2811				
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EXAMINER INITIALS	4	DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS	IF APPRO	
bu !	AA	5,182,220	01/26/93	Ker, et al		437	34	04/02/92	
	AB	5,321,293	06/14/94	Mojaradi, et al.		257	369	07/12/93	
	AC	5,932,914	08/03/99	Horiguchi		257	355	07/22/97	
	AD	6,013,927	01/11/00	Bothra, <i>et al</i> .		257	328	03/31/98	
	AE	2001/0039079	11/08/01	Shin		438	142	07/23/01	
	AF	6,329,691	12/11/01	Finzi		257	355	12/13/99	
	AG	6,344,385	02/05/02	Jun, et a	L .	438	237	03/27	/00
	AH	6,365,939	04/02/02	Noguch	i	257	355	01/27	/00
	AI	6,376,388	04/23/02	Hashimoto,	et al.	438	728	01/22	/97
	AJ	6,559,485	05/06/03	Aoyama		257	211	03/24/00	
	AK								
		1	FOREIC	GN PATENT I	OCUM	ENTS			
		DOCUMENT NUMBER	DATE	COUNTRY		CLASS	SUBCLASS	Transl YES	ation N
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		OTHER I	DOCUM	ENTS (Includ	ng Auth	or, Title, I	Date, Pertine	ent Pages	, Etc
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